

Resolving nanometer-scale variations of doping and strain in single layer MoS₂

Antonis Michail¹, Nikolaos Delikoukos¹, John Parthenios¹, Costas Galiotis^{1,3} and Kostantinos Papagelis^{1,2}

¹*Foundation of Research and Technology Hellas, Institute of Chemical Engineering Sciences, Patras, Greece*

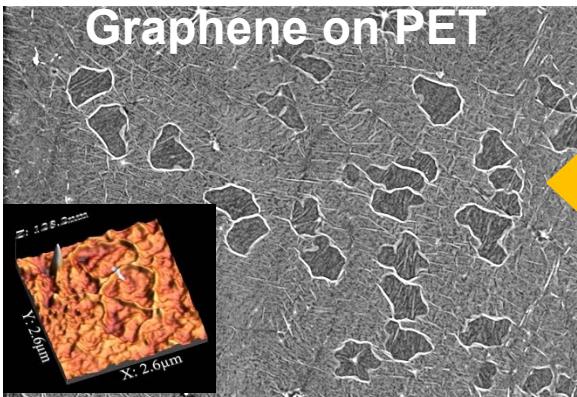
²*Department of Physics, University of Patras, GR-26504 Patras, Greece*

³*Department of Chemical Engineering, University of Patras, Greece*



Native strain and doping in 2D materials

In almost all systems for research and applications 2D materials need to be supported or embedded into other rigid materials including 2D heterostructures

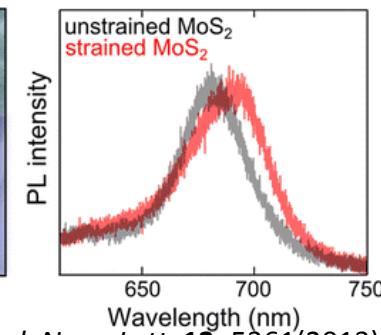
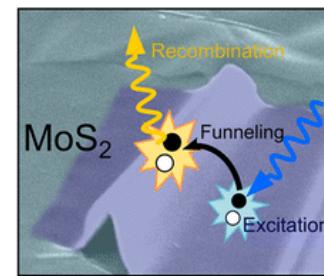


Li et al, ACS-Nano, 9, 3917-3925, 2015

When supported on solid substrates, van der Waals interactions (interfacial adhesion) induce in- and out-of-plane **structural deformations** and **excess charges**.

Monolayer 2D materials experience uncontrollable mechanical strains via the preparation (e.g., exfoliation or chemical vapor deposition) or the transferring processes

Residual strains and charges can alter significantly the electronic and optical properties of 2D materials
(e.g. band gap in MoS₂)

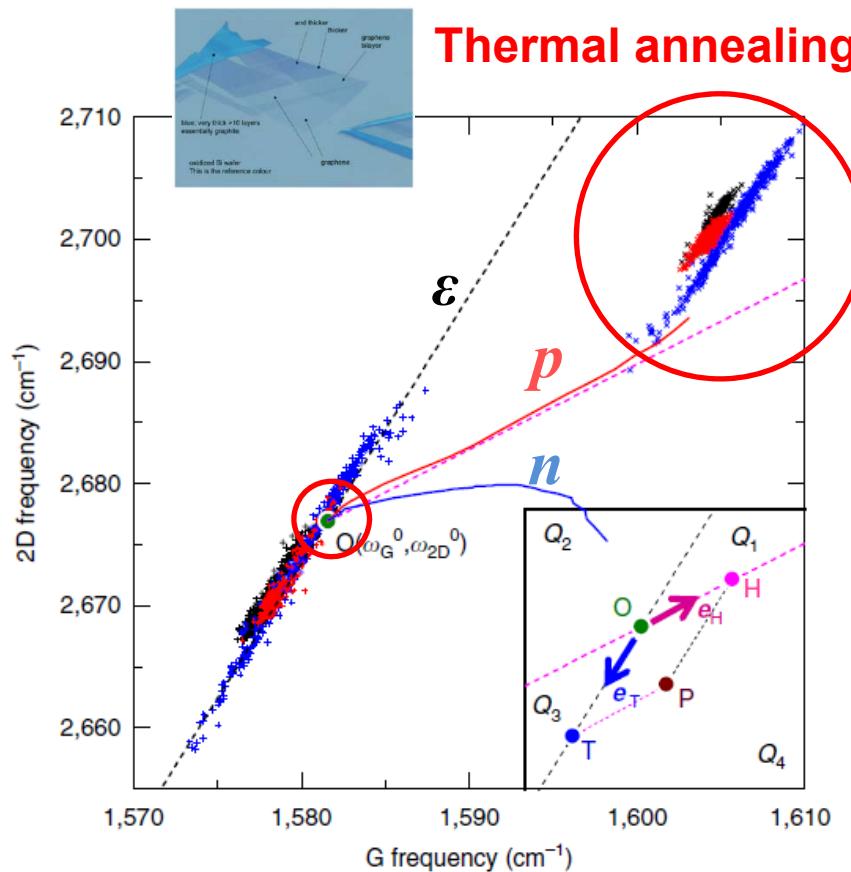


Castellanos-Gomez, A. et al. Nano Lett. 13, 5361(2013)



Mechanically exfoliated graphene on SiO₂

It is assumed that
graphene
strain is biaxial



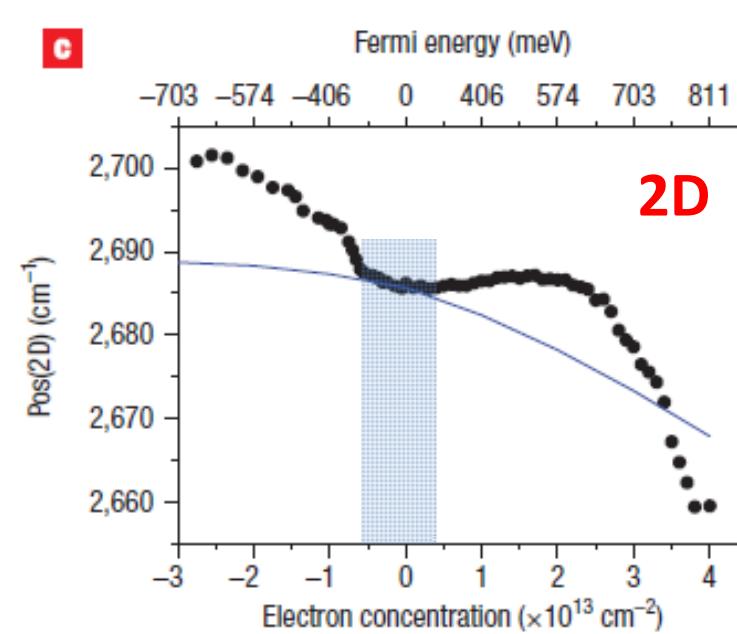
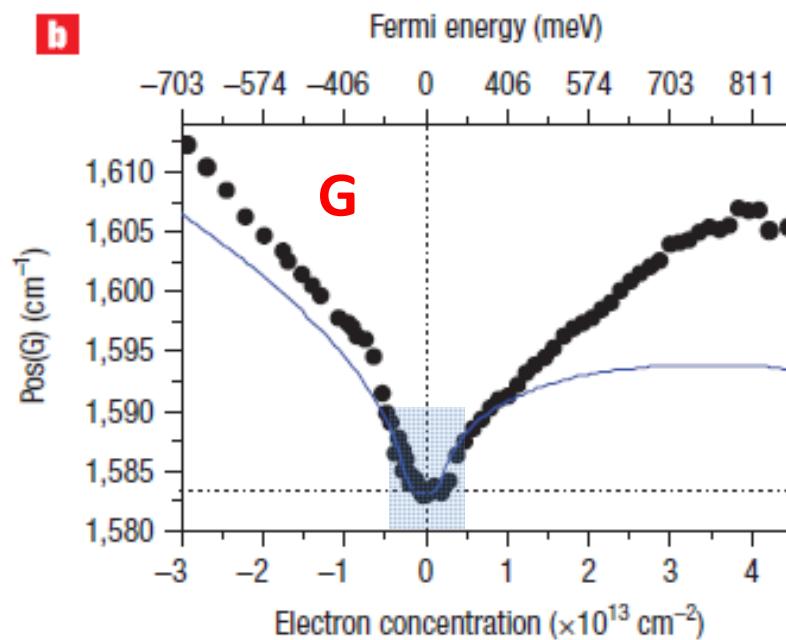
Vector decomposition of **strain (ϵ) & charge density (p or n)**

Pos(2D) vs Pos(G) slope $\sim 2.3 - 2.5$ (strain dominated)

* Lee, J. E., et al. *Nat Commun* 3,1024 (2012).



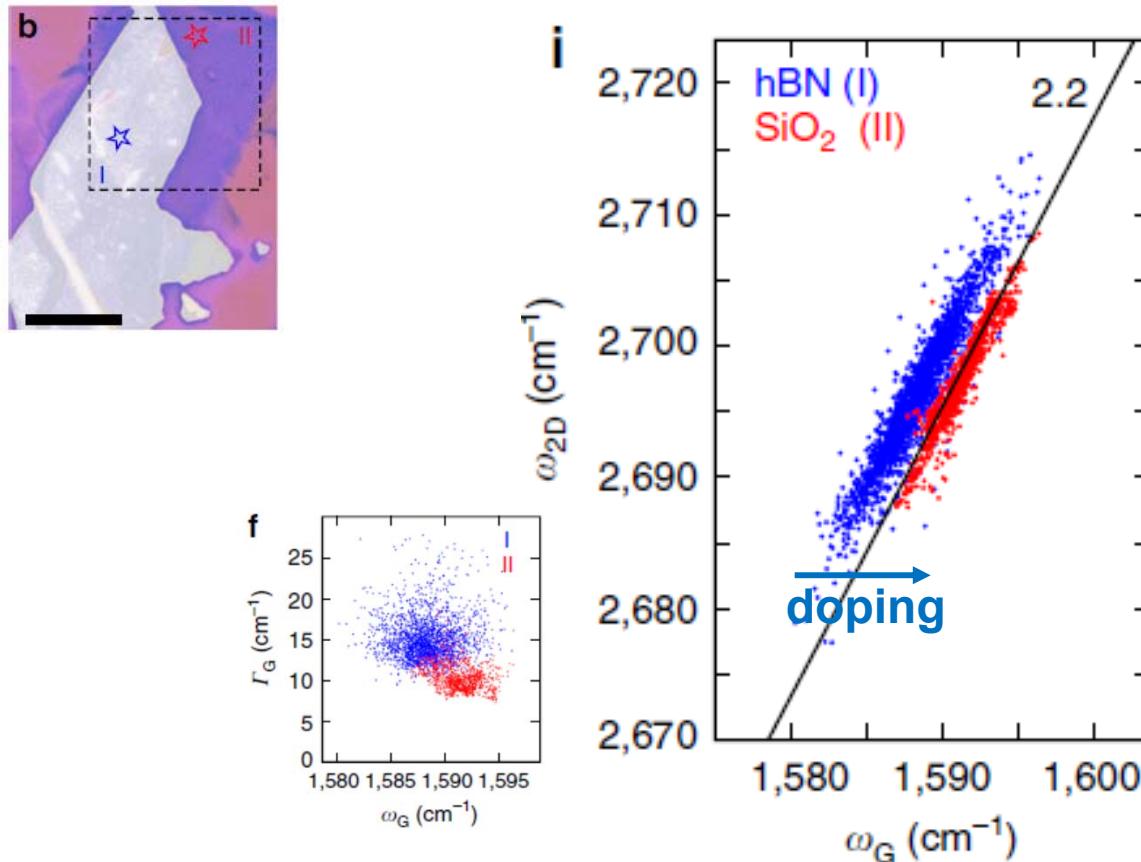
G & 2D vs doping in exfoliated graphene on SiO₂



Das, A. et al. *Nature Nanotechnology* **3**, 210(2008)



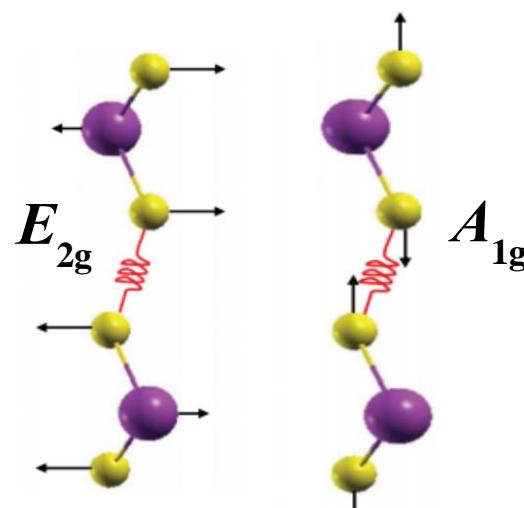
Mechanically exfoliated graphene on h – BN on SiO_2



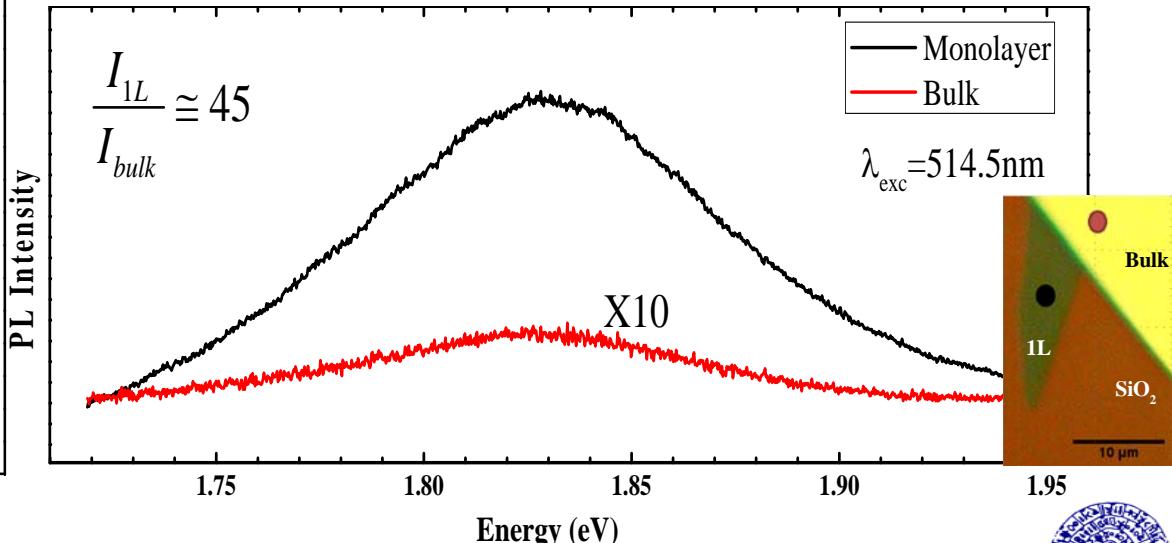
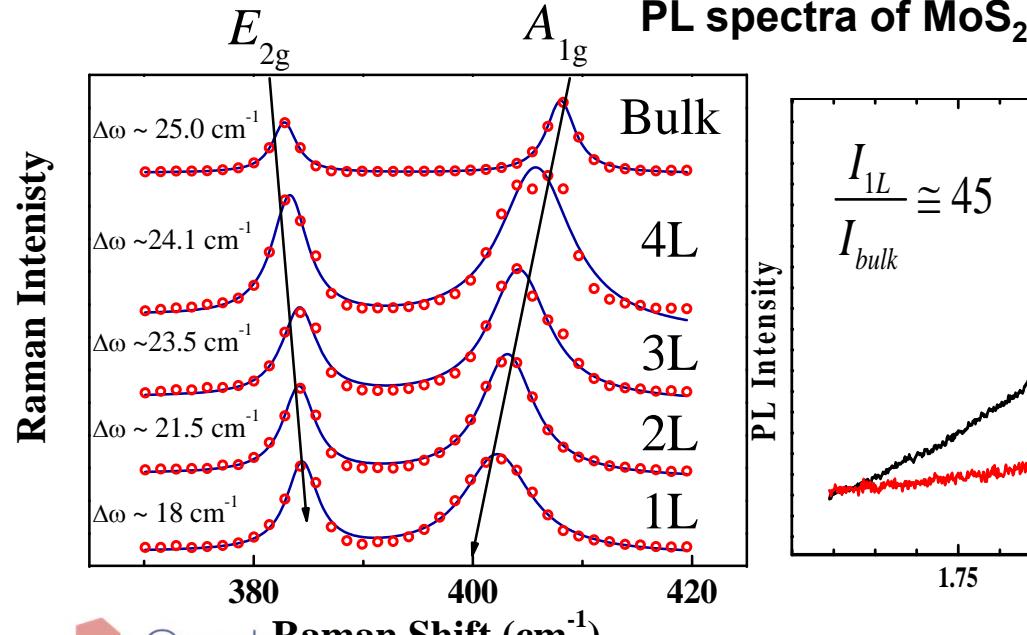
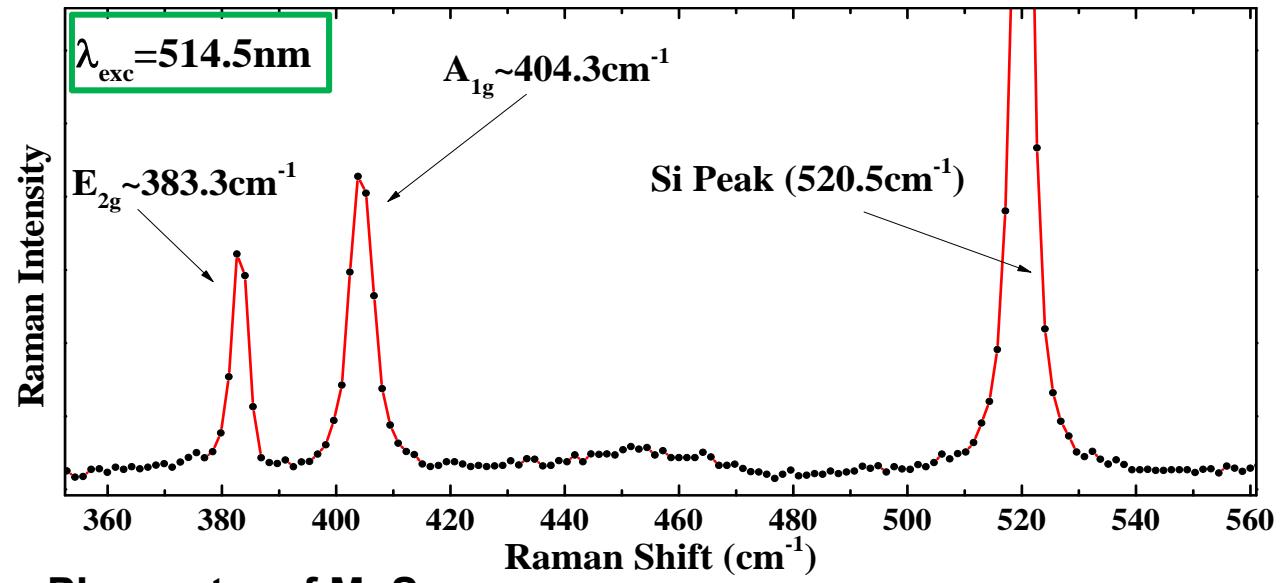
* C. Neuman., et al. *Nat Commun* **6**, 8429 (2015).



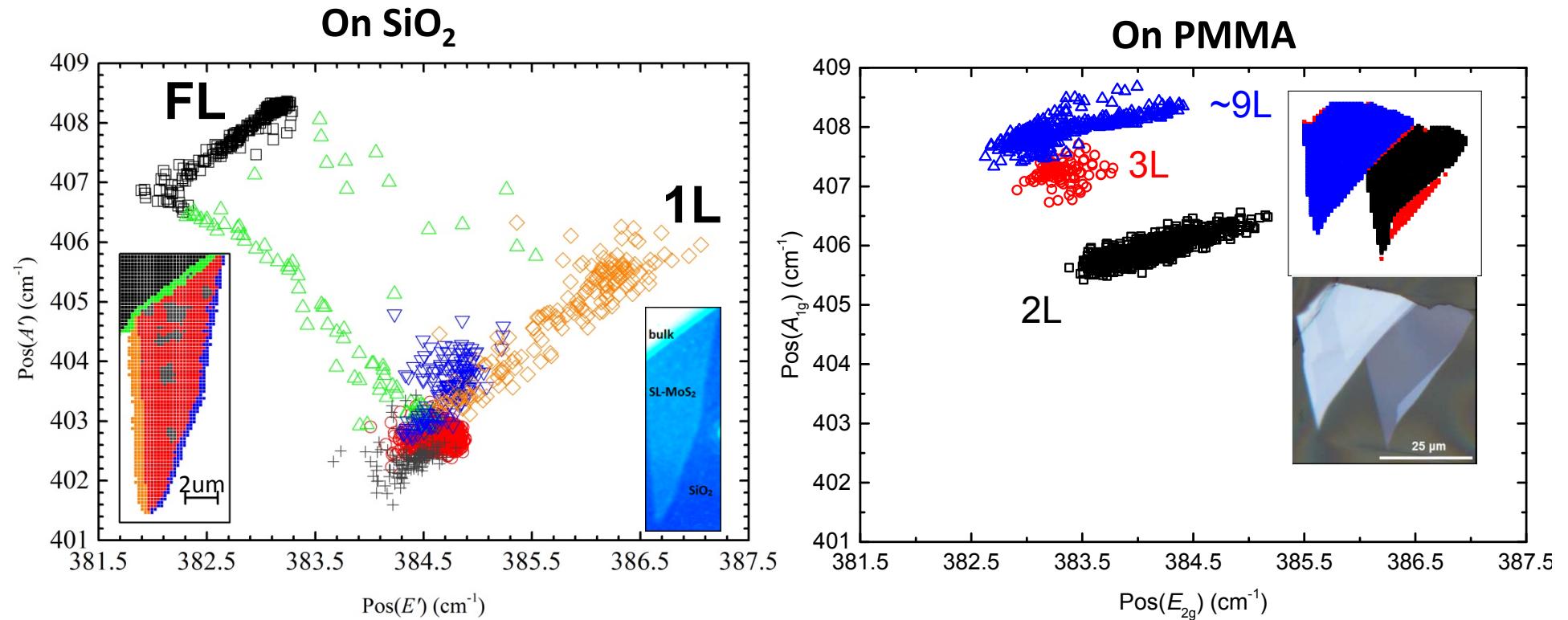
Raman & PL spectroscopy of few layer MoS₂



Phys. Rev. B **84**, 155413



$\text{Pos}(\text{A}_{1g})$ vs $\text{Pos}(\text{E}_{2g})$ of MoS_2 flakes on different substrates



- $\lambda_{\text{exc}} = 514.5 \text{ nm}$
- Scanning step = $0.2 \mu\text{m}$
- 25 spectra/ μm^2 or 3000 spectra



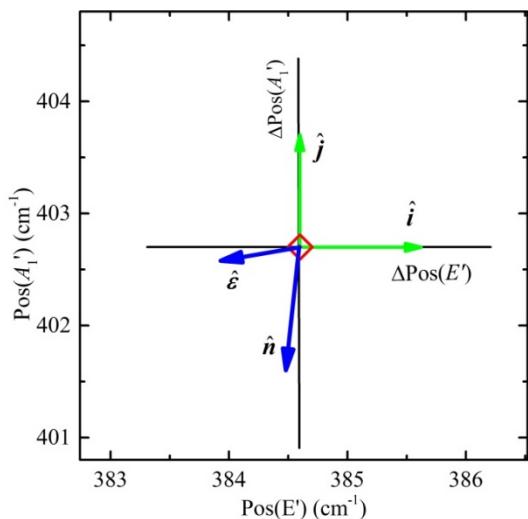
$(\hat{\varepsilon}, \hat{n})$ space determination

$$\delta\omega_{tot} = \delta\omega_{strain} + \delta\omega_{doping}$$

$$\delta\omega_{strain} = -2\gamma\omega_o \varepsilon_{biaxial} \quad \gamma = -\frac{1}{\omega_o} \frac{\partial\omega}{\partial\varepsilon_h}$$

$$\delta\omega_{doping} = -k_n n \quad k_n = \frac{\partial\omega}{\partial n}$$

$$\begin{pmatrix} \Delta\text{Pos}(E') \\ \Delta\text{Pos}(A_1') \end{pmatrix} = \begin{pmatrix} -2\gamma(E')\text{Pos}(E')_0 & k_n(E') \\ -2\gamma(A_1')\text{Pos}(A_1')_0 & k_n(A_1') \end{pmatrix} \begin{pmatrix} \varepsilon \\ n \end{pmatrix}$$

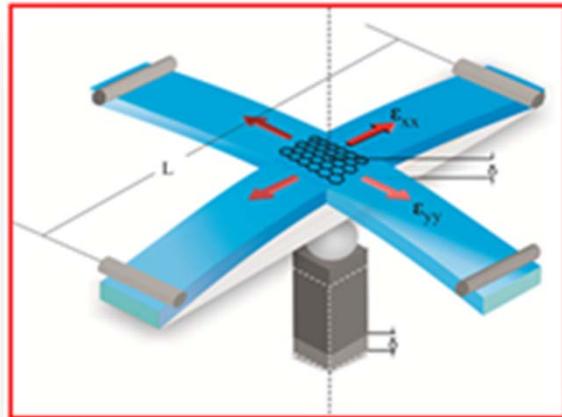


	γ	$k_n (\times 10^{-13} \text{ cm})$
E'	1.08 (exp)	-0.33
A ₁ '	0.15	-2.22

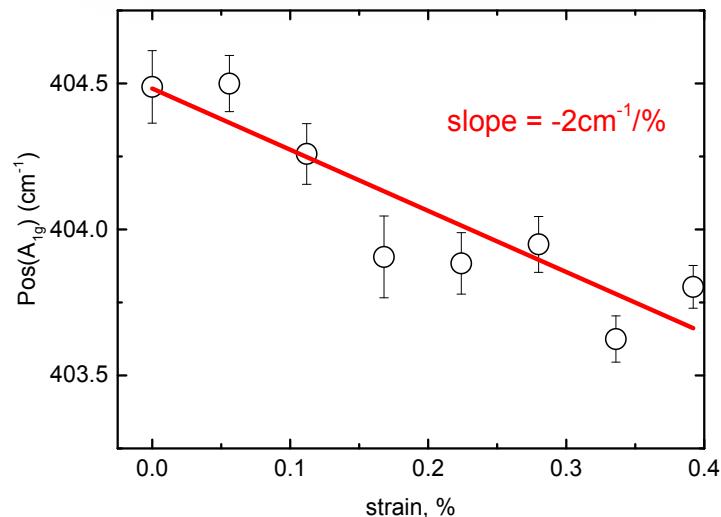
Chakraborty B. Physical Review B, 2013. **87**(8)

Biaxial deformation of single layer MoS₂

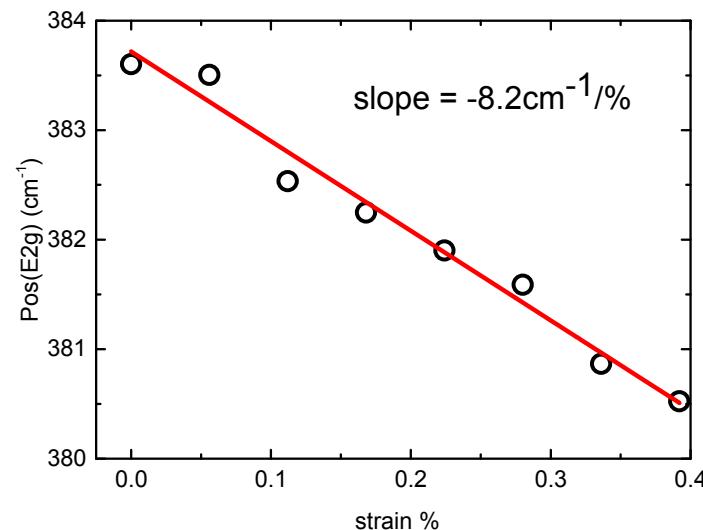
Measuring the Gruneisen parameter



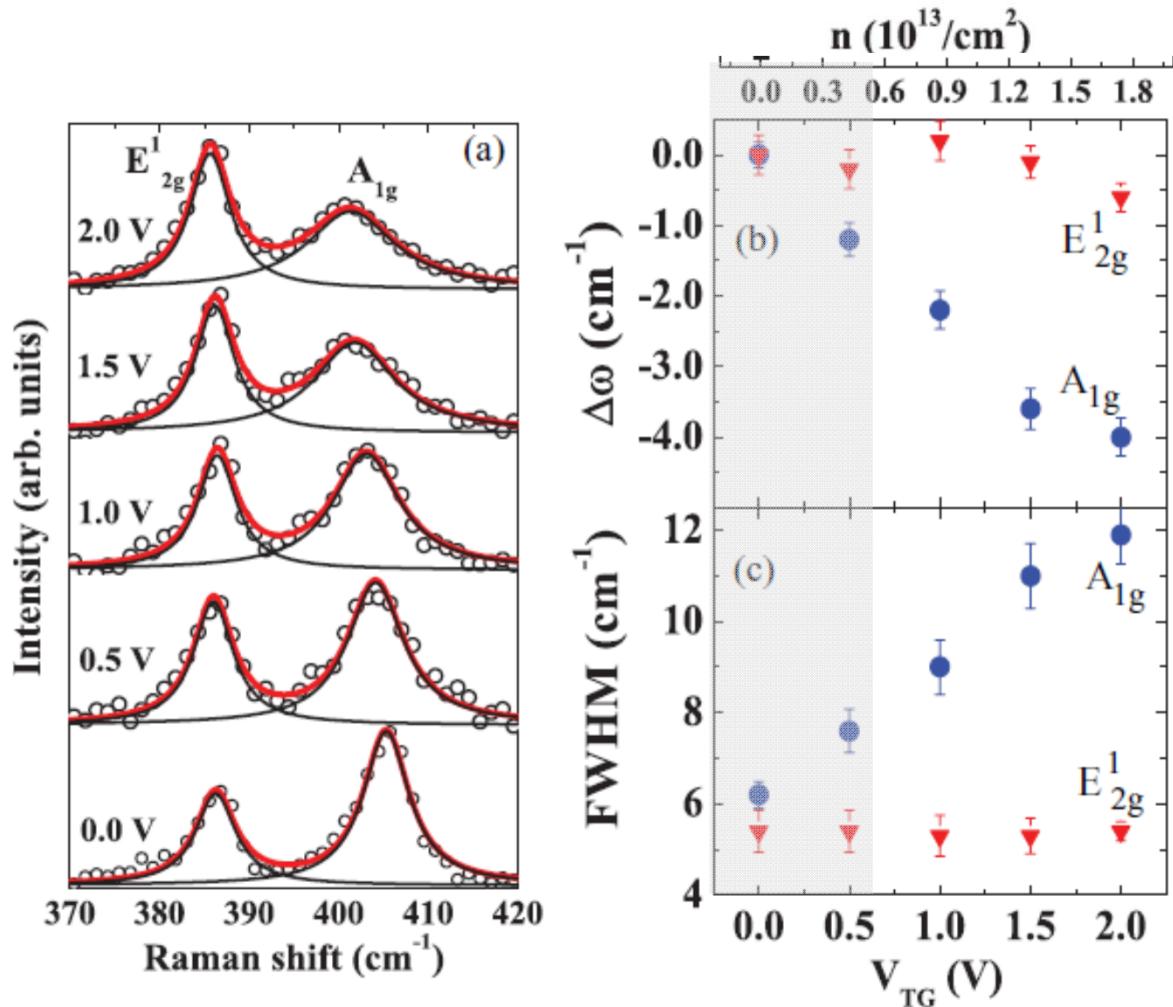
Androulidakis C. et al., Sci. Rep. 5, 18219 (2015)



$$\gamma(\omega) = -\frac{1}{\omega_0} \frac{\delta\omega_{strain}}{2\varepsilon_{biaxial}}$$



The effect of doping in 1L exfoliated MoS₂ on SiO₂

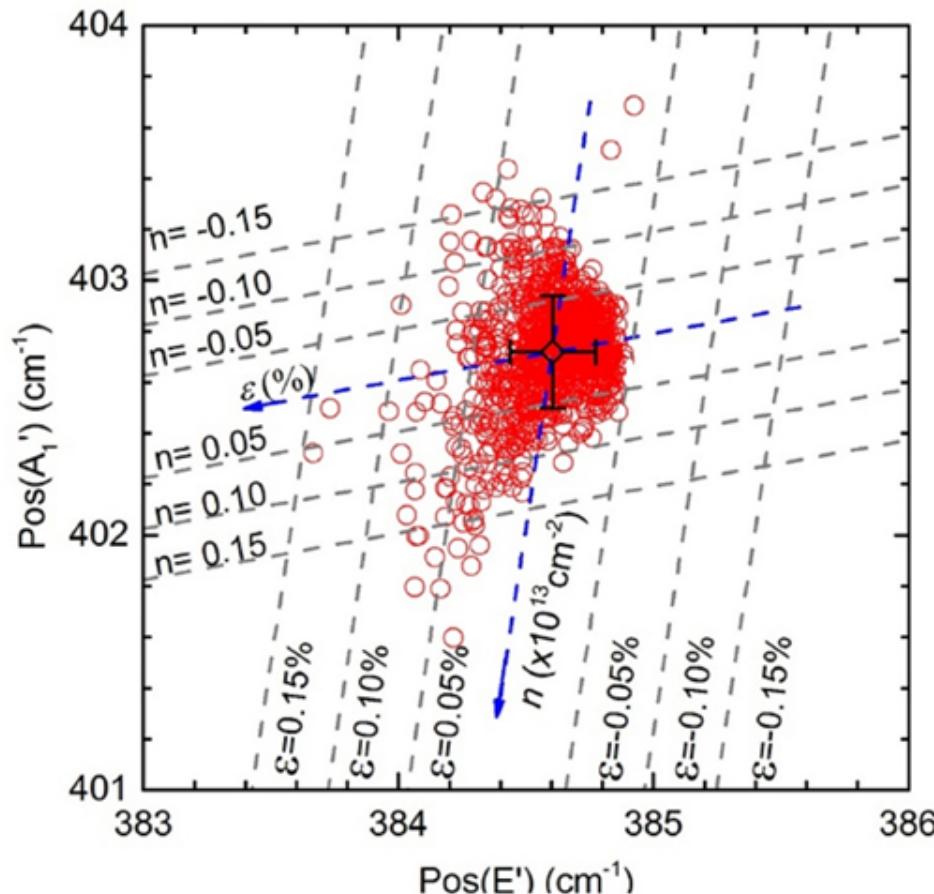


E_{1g}
is less
sensitive in
doping than
 A_{1g}

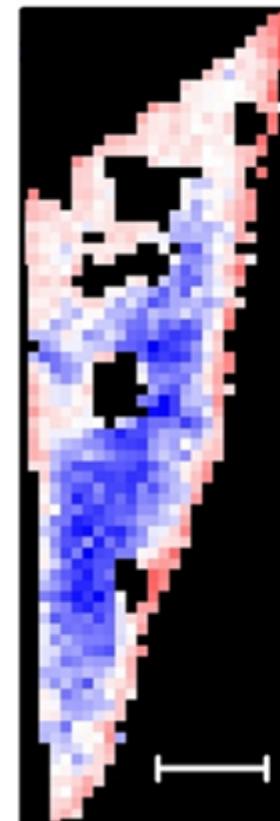
Chakraborty, B. et al. Phys. Rev. B 85, 161403 (2012)



$\text{Pos}(A_1')$ vs $\text{Pos}(E')$ and the $(\hat{\varepsilon}, \hat{n})$ space

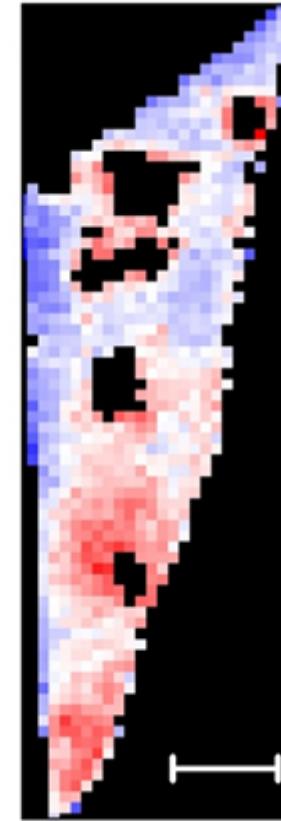


ε



Raman
Strain (%)

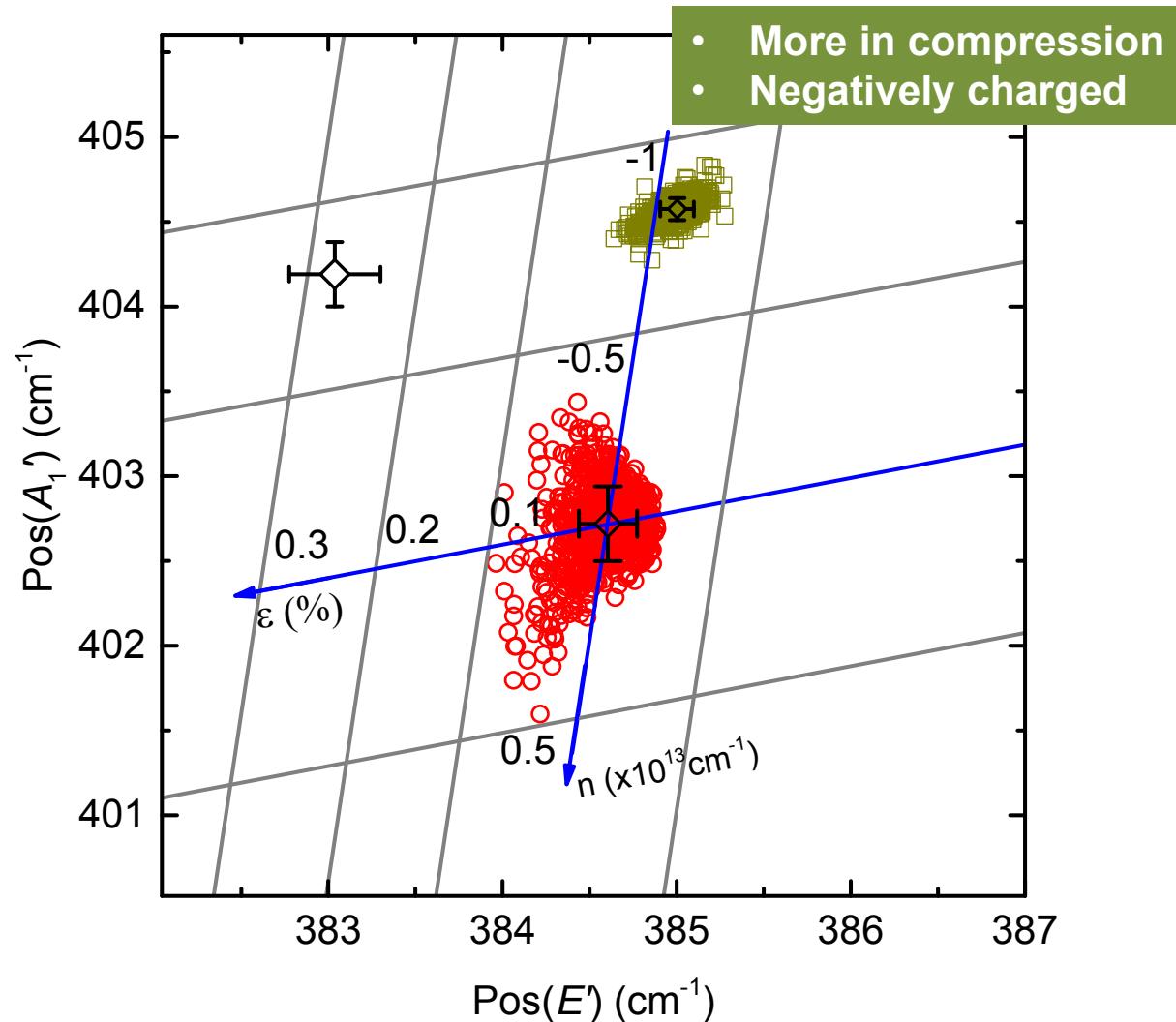
n



electron
concentration
 $(\times 10^{13} \text{ cm}^{-2})$

Pos(A') vs Pos(E')

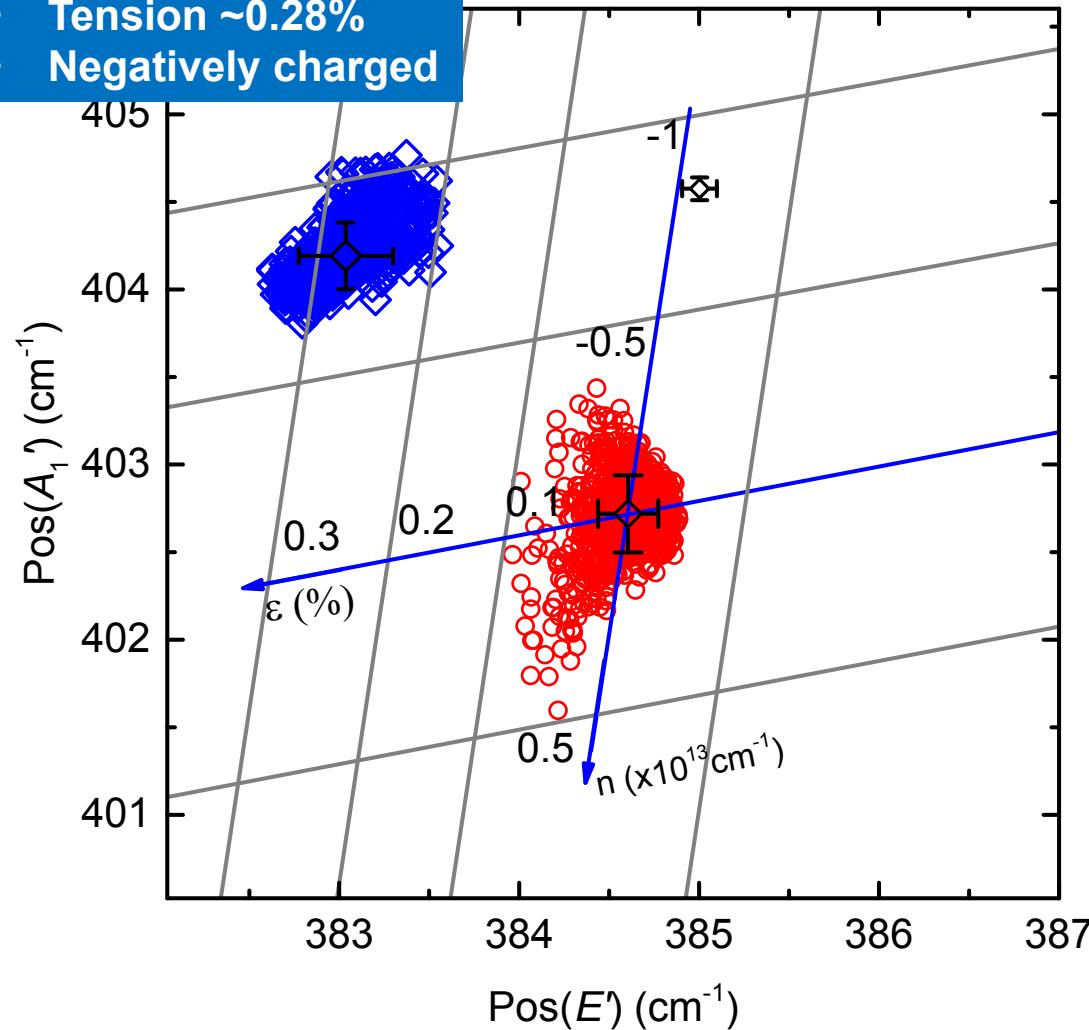
1L MoS₂ exfoliated onto SiO₂



Pos(A') vs Pos(E')

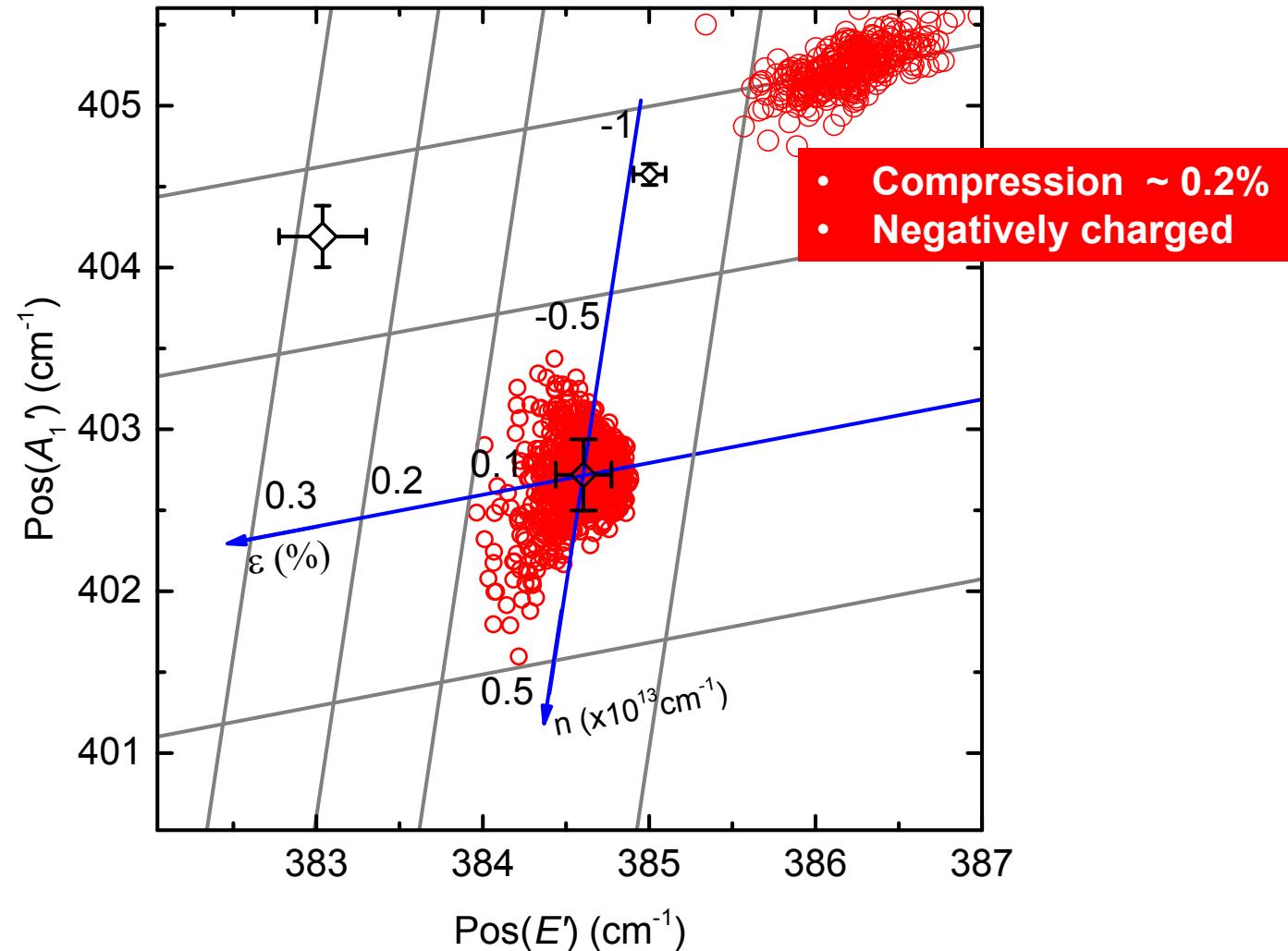
1L MoS₂ grown onto SiO₂ by CVD

- Tension ~0.28%
- Negatively charged

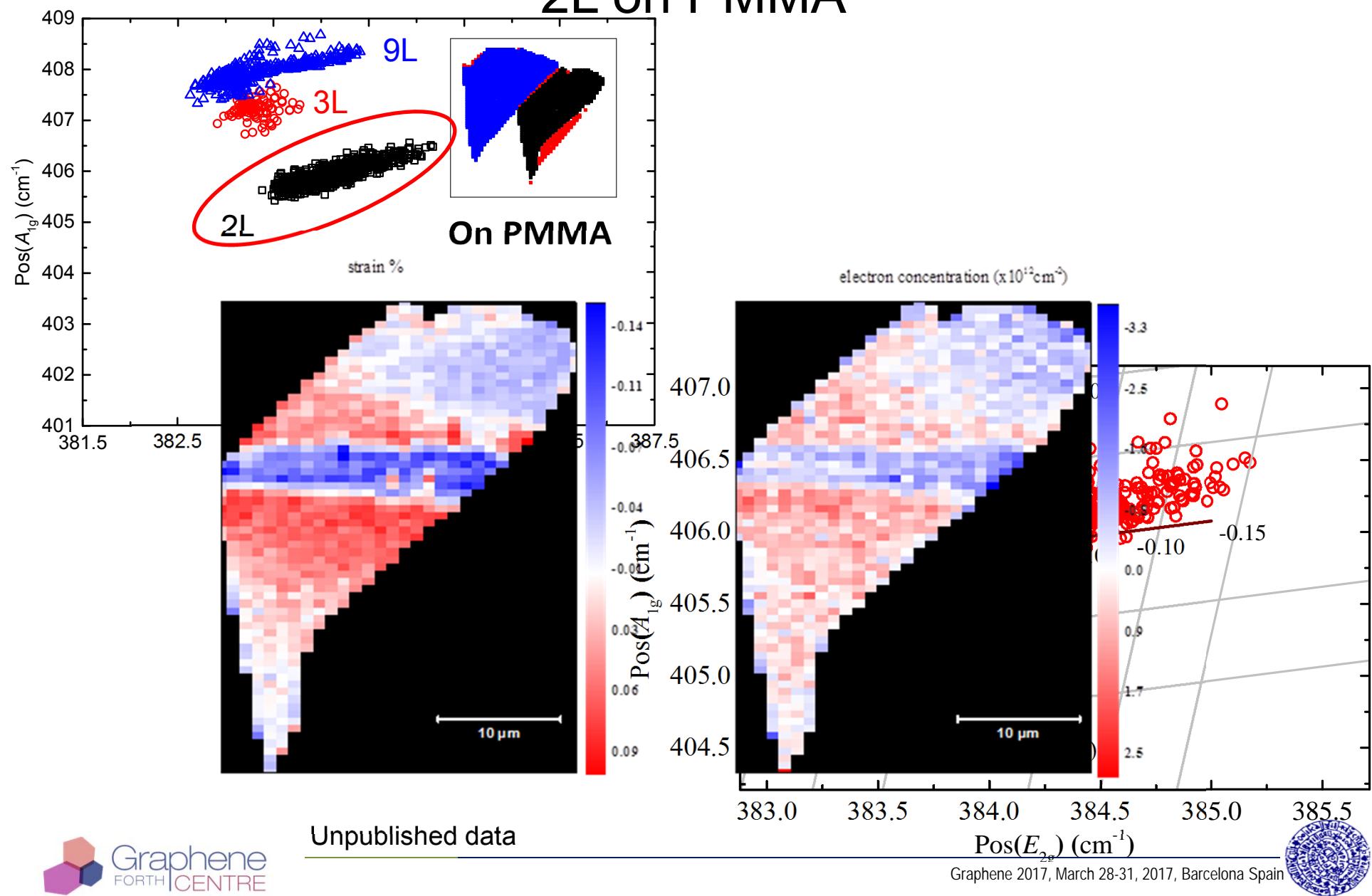


Pos(A') vs Pos(E')

CVD grown 1L MoS₂ transferred onto PMMA

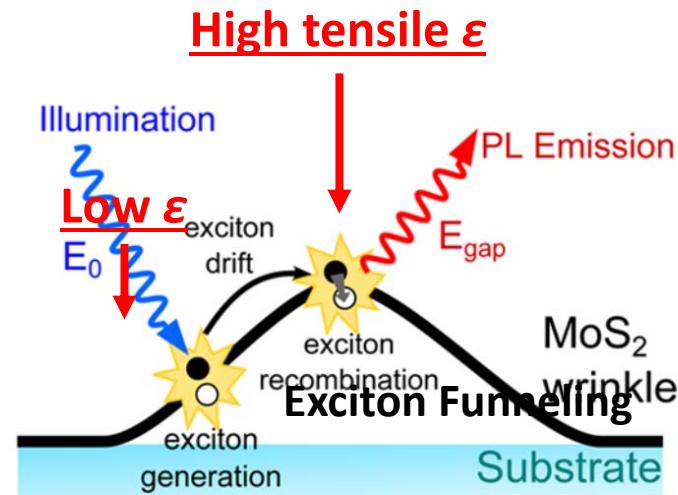
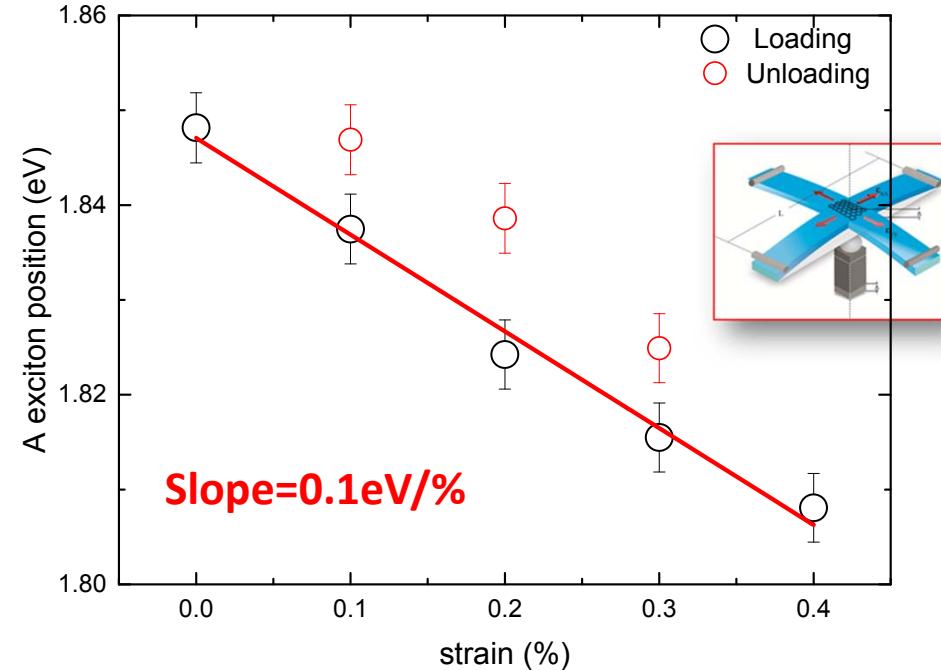
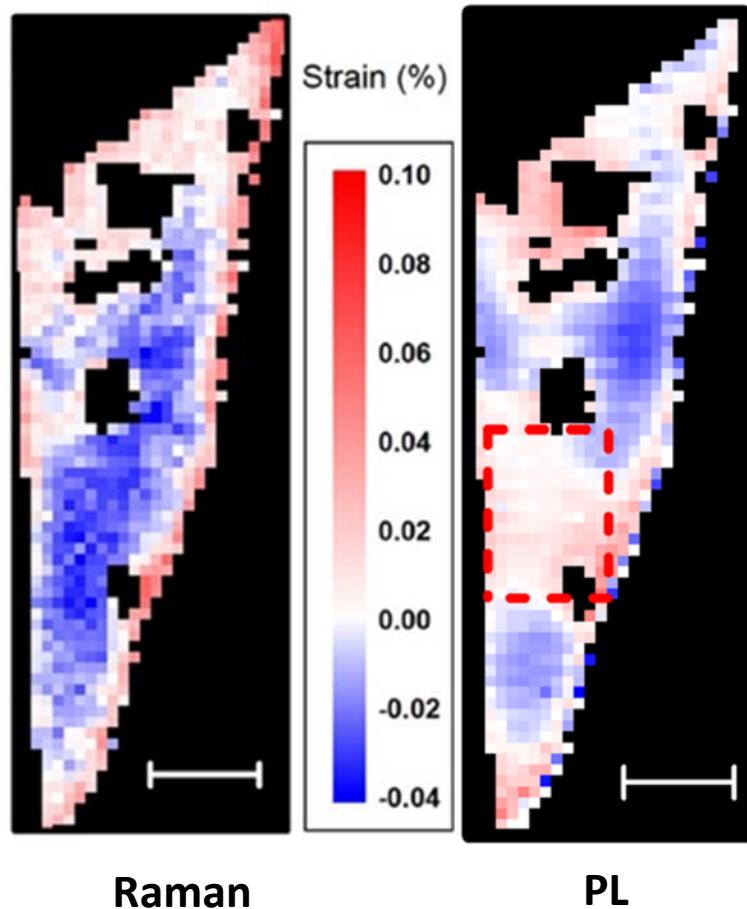


$\text{Pos}(A_1')$ vs $\text{Pos}(E)$ and the $(\hat{\varepsilon}, \hat{n})$ space 2L on PMMA

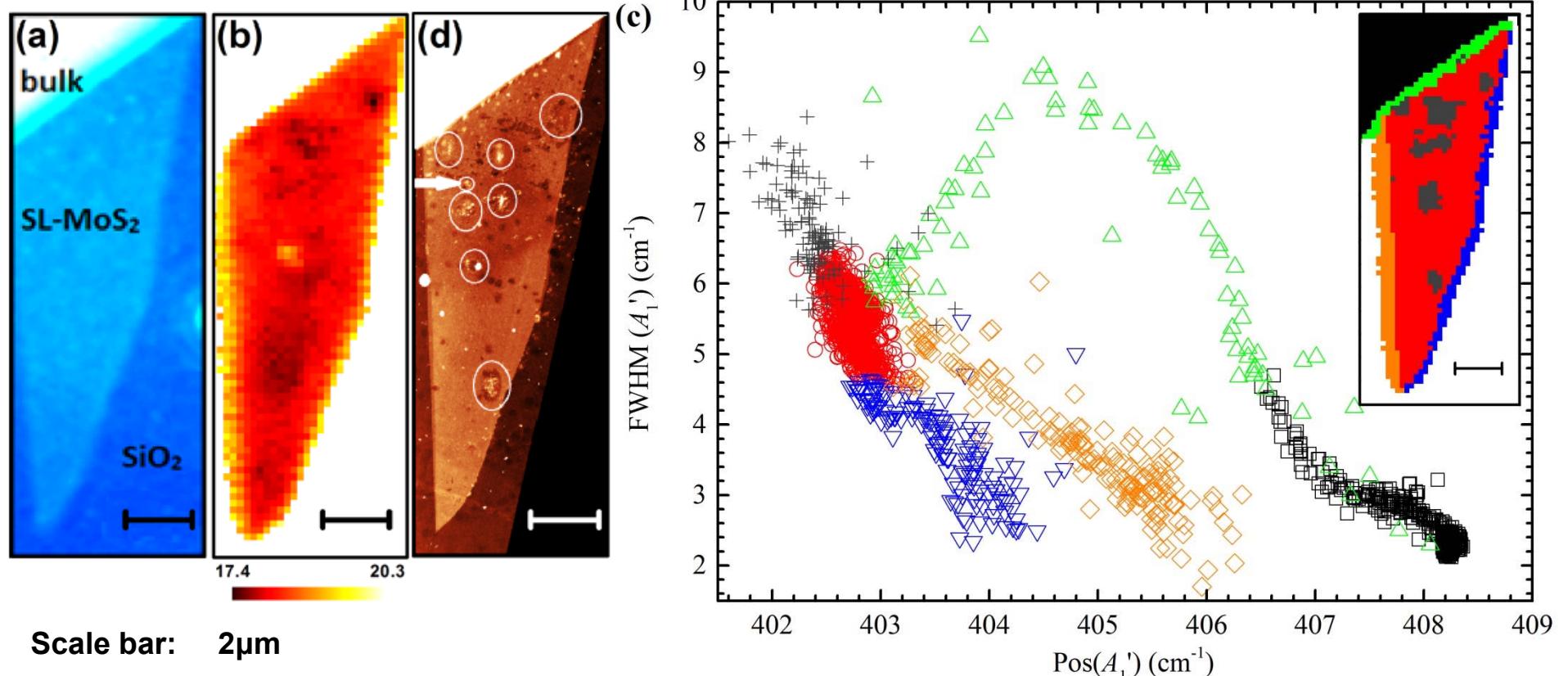


Strain evaluation using PL

$$\Delta E_g = (-0.1 \text{ eV} / \%) \epsilon_{\text{biaxial}}$$



FWHM(A_1') vs Pos(A_1')

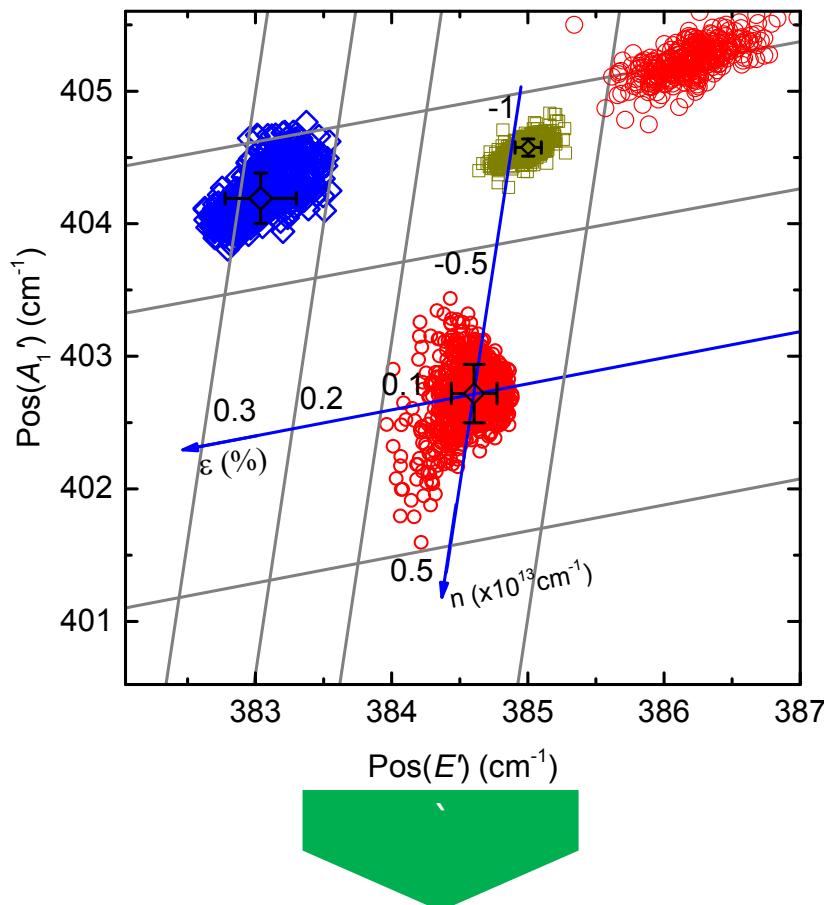


- Discriminate defects with spatial resolution below 1 μm
- Voight profiles to deconvolute the spectrograph response



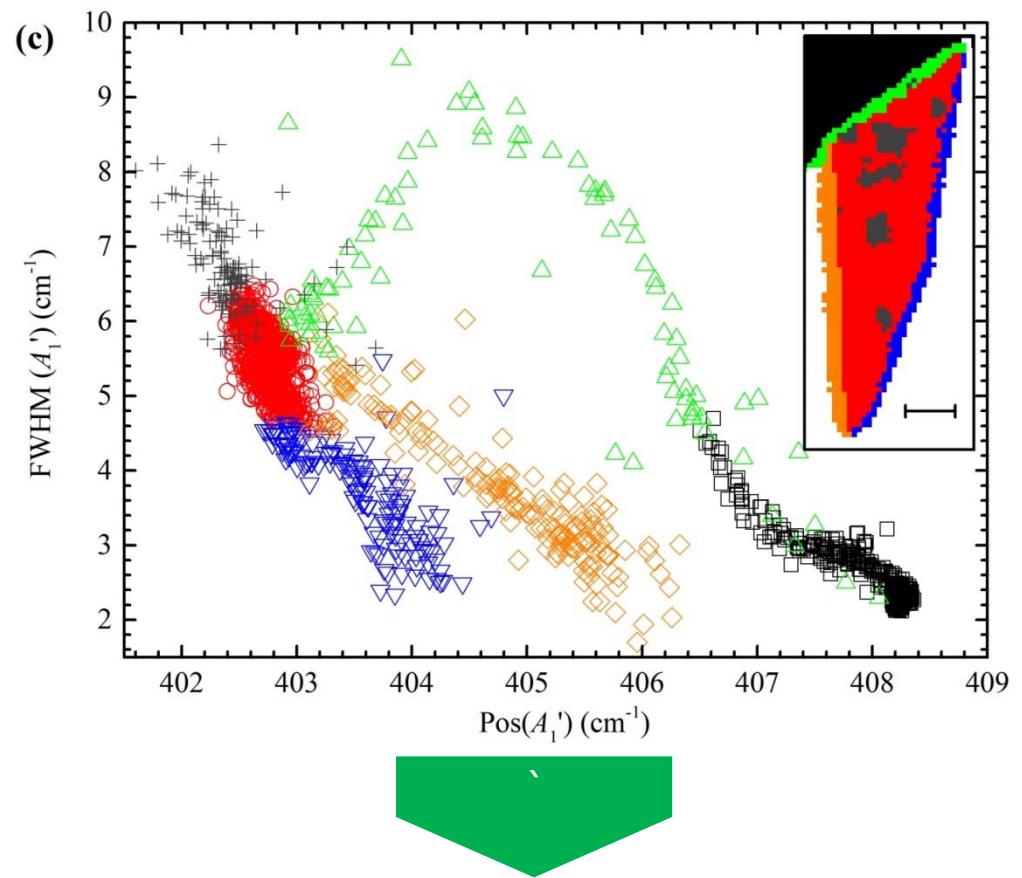
Conclusions

Correlation I



ε, n deconvolution

Correlation II



Discrimination of structural
features with spatial resolution
below 1 μm



ACKNOWLEDGEMENTS



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Thanks very much for your attention

